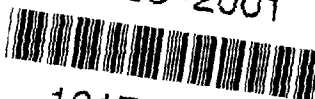




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To the Honorable Commissioner of Patents and Trademarks.
documents or copy thereof.

the attached original

1. Name of Conveying party(ies): Philippe Coronel; Renzo Mascagnan; Philippe Lacombe

3. Nature of Conveyance: Assignment

2. Name & address of receiving party(ies)

Name: International Business Machines Corporation

Execution Date: 05/18/01; 05/18/01; 05/18/01

Street Address: New Orchard Road

City: Armonk State: New York ZIP: 10504

4. Application number(s) or patent number(s):

Title of Application: METHOD OF FORMING STI OXIDE REGIONS AND ALIGNMENT MARKS IN A SEMICONDUCTOR STRUCTURE WITH ONE MASKING STEP

If this document is being filed together with a new application, the execution date of the application is:

A. Patent Application No(s).

Docket No. FR919990047US1

Serial No. 09/779,388

B. Patent No(s)

Additional numbers attached? ☐ Yes ☒ No5. Name and address of party to whom
correspondence concerning document
should be mailed:

Name: Tiffany L. Townsend

Street Address:

International Business Machines Corp.
Intellectual Property Law Dept.
2070 Route 52
Dept. 18G / Bldg. 300-482
Hopewell Junction, New York 125336. Total number of applications and
patents involved: 1

7. Total fee (37 CFR 3.41): \$40.00

☐ Enclosed☒ Authorized to be charged to
deposit account8. Deposit A/C no.: 09-0458 (FI-287)

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9. Statement of signature:

To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is
a true copy of the original document.

Tiffany L. Townsend, Registration No. 43,199

Name of Person Signing

Telephone No. (845) 894-3668

Signature

Date

Total number of pages including cover sheet, attachments, and document: 3

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE AS FIRST CLASS MAIL IN
AN ENVELOPE ADDRESSED TO: ASSISTANT COMMISSIONER FOR PATENTS, WASHINGTON, D.C. 20231.

Date of Deposit: May 24, 2001

Name of Person Making Deposit: Karen Cing-Mars

Signature: Karen Cing-Mars

ASSIGNMENT

WHEREAS, we

(1) **Philippe Caronai** of France

and

(2) **Renzo Mascagnon** of France

and

(3) **Philippe Lecombe** of France

have invented certain improvements in

METHOD OF FORMING STI OXIDE REGIONS AND ALIGNMENT MARKS IN A SEMICONDUCTOR STRUCTURE WITH ONE MASKING STEP

and executed a United States patent application therefor on:

(date that inventors signed the declaration)

(1) 05/18/ 2001 AND (2) 05/18/ 2001.

(3) 05/18/ 2001

Whereas, INTERNATIONAL BUSINESS MACHINES CORPORATION, a corporation of New York, having a place of business at Armonk, New York 10504, (hereinafter called IBM), desires to acquire the entire, right, title and interest in the said application and invention, and to any United States and foreign patents to be obtained therefor;

Now therefore, for a valuable consideration, receipt whereof is hereby acknowledged, I, the above named, hereby sell, assign and transfer to IBM, its successors and assigns, the entire right, title and interest in the said application and the invention therein disclosed for the United States and foreign countries, and all rights of priority resulting from the filing of said United States application, and I request the Commissioner of Patents to issue any Letters Patent granted upon the invention set forth in said application to IBM, its successors and assigns; and I hereby agree that IBM may apply for foreign Letters Patent on said invention and I will execute all papers necessary in connection with the United States and foreign applications when called upon to do so by IBM.

